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MEMS micromirror based light sheet generator for biomedical imaging

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Abstract—Two MEMS micromirrors with resonant or static actuation are used as a MEMS enabled light sheet generator, with light sheet dimensions of 3.5μm by 550μm and offset positioning of 150μm in the focal plane.

Keywords—MEMS, micromirror, electrostatic and electrothermal actuation, light sheet, biomedical imaging

I. INTRODUCTION

The use of light sheets as sculptured excitation for biomedical imaging has had growing interest over the last decade, following the demonstration of selective plane illumination microscopy by Huisken et al. [1]. Two general concepts are commonly used. The creation of a light sheet through the use of cylindrical lenses, with a compact concept being demonstrated recently [2], or the use of scanned single point laser beams [3]. The advantages of using scanning systems are the extra flexibility for tailored dimensions of the light sheet and the potential for easier synchronization control. The integration of MEMS optical scanning micromirrors allows the prospect of further miniaturization together with added functionality through positioning control in the 3D sample space.

In this paper, a concept for a miniaturized light sheet illumination beam path is presented, incorporating two MEMS micromirrors as beam shaping elements. The two single crystal silicon micromirrors are used for light sheet generation and its positioning in the focal plane. They have electrostatic (ES) comb-drive actuation for the 1D scan of a laser point source and electrothermal (ET) actuation for 2D tip-tilt control to position the light sheet in the focal plane [4]. The illumination system uses a fiber-coupled 488nm Argon-Ion laser as source and is experimentally evaluated for its spatial characteristics in the focal plane.

II. MICROMIRROR DESIGN & CHARACTERIZATION

Both micromirrors are fabricated using a commercial silicon-on-insulator multi-user process (SOI-MUMPs) run by MEMSCAP Inc. The micromirror designs (see Fig. 1) use a silicon device layer of 25μm thickness for the ES comb-drive actuated scanning mirror and a 10μm thickness for the ET actuated positioning mirror. Both are fully backside released through a deep reactive ion etch step. The scanning mirror has an active mirror surface diameter of 700μm, torsion springs of 550μm length and 60μm width and 20 comb-pairs with 10μm thickness and 6μm electrode gap placed at the edges of the mirror surface. Spring connections are placed on the edge of the mirror surface and the substrate-torsion beam connection to reduce stress and dynamic surface deformation of the mirror surface. The mirror surface radius of curvature (ROC) was measured as 0.4m. The positioning micromirror has an active mirror diameter of 1.2mm with 4 actuators placed symmetrically around the circumference. Each actuator consists of 3 beams with width of 40μm and length of 1.8mm (for horizontal tilt) and 1.7mm (for vertical tilt). This enables decoupling of the resonance modes of both axes. Out-of-plane movement of the actuator tip is achieved through Joule Heating.

![Fig. 1: Schematic of (a) the resonant scanning mirror and (b) the static positioning mirror.](image1)

![Fig. 2: Tilt angle vs voltage for static mirror (top) and tilt angle vs frequency at 150Vpp for resonant scanning mirror (bottom).](image2)

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resulting from a current flow through the outer actuator beams while the non-actuated central beam acts as mechanical constraint directing the heat induced deformation. Serpentine springs connect each actuator to the mirror surface. The micromirror had a surface ROC of 0.07m. Static displacement can be achieved through DC voltage signals on the actuators.

The experimental characterization of both mirrors is shown in Fig. 2. The ET static positioning mirror (top) is actuated with a DC voltage between 0-15V, with the resulting optical tilt angles reaching 4.9° and 3.4° for 15V actuation. The ES resonant scanning mirror (Fig. 2, bottom) is actuated with a square wave drive voltage with 150Vpp and 0V minimum level. A first harmonic drive scheme is used, resulting in the actuation frequency being double the mechanical movement frequency of the mirror. The resulting angular response shows a spring softening behavior, with hysteresis occurring between 48.65kHz and 48.8kHz and a maximum full optical scan angle of 22°. The occurring hysteresis leads to an applied actuation frequency of 48.8kHz with an optical scan angle of 15.5°.

III. MEMS LIGHTSHEET GENERATION

The optical setup to create the scanned light sheet with 2D positioning capability is shown in Fig. 3. A fiber-coupled 488nm Argon-Ion laser with 1.5mW output power is used as excitation source for the light sheet generator. The collimated beam is scanned by the ES micromirror with an incident beam diameter of 500μm and imaged onto the ET positioning mirror with a 4f system comprising of two 10mm achromatic doublet lenses (Thorlabs AC050-010-A). The scan line reflected on the ET mirror is collimated with a further 10mm achromatic doublet lens, with the scanned spot being magnified by a 1:3 telescope to a beam diameter of 1.5mm. The 30mm achromatic doublet lens (Thorlabs AC127-030-A) used as second telescope lens collimates the scanned beam. A 7.5mm achromatic doublet lens (Thorlabs AC050-008-A) is used as telecentric excitation lens for the system, resulting in a calculated point spread function FWHM of 2.5μm at the focal point and a light sheet height of 670μm for a scan angle of 15.5°. The optical parameters were simulated using Optenso’s Optalix ray trace software, leading to a working distance after the focusing lens of 5.13mm. The overall optical footprint between fiber-collimation and focal point is 13.5cm x 5cm.

The experimental setup of the system collimated the laser beam output after the ES micromirror while taking into account its ROC. The measured light sheet dimensions for a scan movement with 24.4kHz and 15.5° are shown for the center position and at positioning on the maximum y-axis (Fig. 4). The light sheet dimensions were measured using a knife-edge with a 1μm step size translation stage. The resulting light sheet has a FWHM width of 3.5±1μm at the center and 2.6±1μm at a position 150μm above the center line. The light sheet length was measured at 550±5μm and 540±5μm for these positions. An intensity increase can be seen at the edges of the light sheet due to the slower scan speed at the change of the MEMS resonant movement direction. The Rayleigh range of the light sheet is therefore around 60μm, leading to a confocal parameter of 120μm.

IV. CONCLUSION

The initial concept and characterization of a MEMS enabled light sheet generator is presented, using two micromirrors with ES and ET actuation for the light sheet generation and positioning. Scanned light sheets with width of 3.5μm and length of 550μm are generated and their positioning in the focal plane with up to 150μm offset is demonstrated. This concept is the first step to a fully MEMS controlled miniaturized light sheet microscope.

REFERENCES